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000	Strate for form 14407 10			Application Number	10/589,399-Conf. #7126
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S	STATEMENT BY APPLICANT			First Named Inventor	Guo-Quan LU
				Art Unit	1793
(Use as many sheets as necessary)			necessary)	Examiner Name	Y. Takeuchi
Sheet	1	of	2	Attorney Docket Number	124617.0118

	U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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Initials*	No.1	Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Or Relevant Figures Appear			
	E	JP-07126556-A	05-16-1995	Tatsuta Densen Kk				
	 							
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Sheet	2	of	2	Attorney Docket Number	124617.0118

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²		
	J	Wong Wai Kwan et al. "Low temperature sintering process for deposition of nano-structured metal for nano IC packaging". ELECTRONICS PACKAGING TECHNOLOGY, 2003 pp. 551-556.			
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